

Docket No.: NY-RPP 202-US (PATENT)

Examiner: Not Yet Assigned

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE.

In re Patent Application of:

Rudolf Beckmann

Application No.: 10/552,677 Confirmation No.: 2418

Filed: April 8, 2004 Art Unit: 1712

For: HIGH FREQUENCY PLASMA JET SOURCE AND METHOD FOR IRRADIATING A

SURFACE

NOTIFICATION OF LOSS OF ENTITLEMENT TO SMALL ENTITY STATUS

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Assignee, LEYBOLD OPTICS GMBH, hereby notifies the Patent and Trademark

Office that it is not entitled to status as a small entity, and that the claim for small entity status
filed by the Applicant is hereby withdrawn.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 50-0624, under Order No. NY-RPP 202-US from which the undersigned is authorized to draw.

Dated: September 1, 2011 Respectfully submitted,

By James R. Crawford/ James R. Crawford Registration No.: 39,155 FULBRIGHT & JAWORSKI L.L.P. 666 Fifth Avenue New York, New York 10103 (212) 318-3000 (212) 318-3400 (Fax) Attorney for Applicant